

## THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group

Art Unit:

1762

Attorney

Docket No .:

NPO0005-02

Applicant:

Keiji Ishibashi

Invention:

A HOT ELEMENT CVD APPARATUS AND A

METHOD FOR REMOVING

A DEPOSITED FILM

Serial No.:

09/633,002

Filed:

August 4, 2000

Examiner:

Wesley D. Markham

**CERTIFICATE OF MAILING** 

I HEREBY CERTIFY THAT THIS correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Bex 1450, Alexandria, VA 22313-1450 on: March 28, 2005.

ANTHONY NEWYK, REG. NO. 24, 871

Name of Registered Representative

March 28, 2005

Date

## **AMENDMENT AFTER FINAL**

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

W-7/05

Sir:

In response to the Final Office Action of December 30, 2004, please amend the application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 4 of this paper.